

## Two TMPs breakdown:

1. Atmospheric pressure at foreline
2. Unknown reason



Rb migrating from the source to extraction  
(or glass tube) area causing instabilities and sparking.  
Solution: through cleaning of ion source

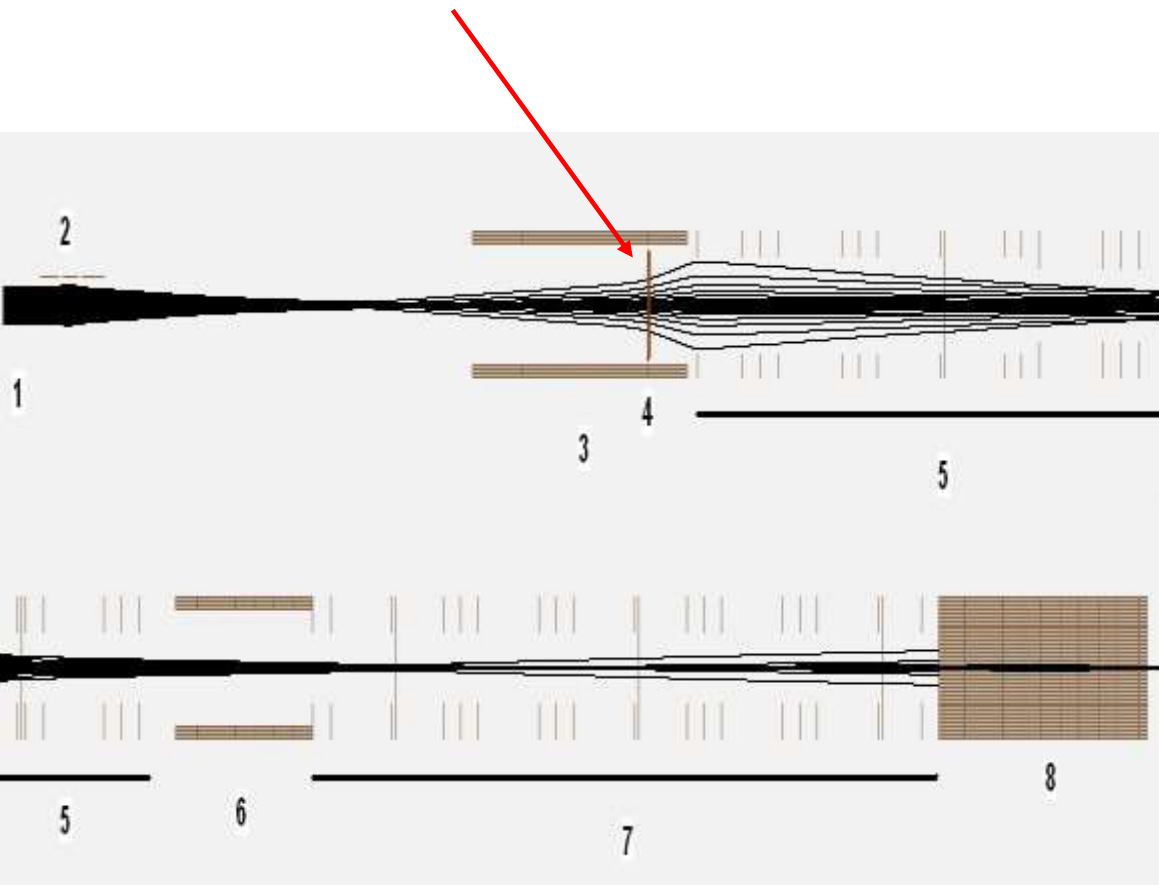




Belt worn out after  
~20000 working hours

# Some upgrades to the optics of EN: LE improvement - gridded lens addition

Gridded lens (4) in addition to einzel lens (2) acts as zoom-lens





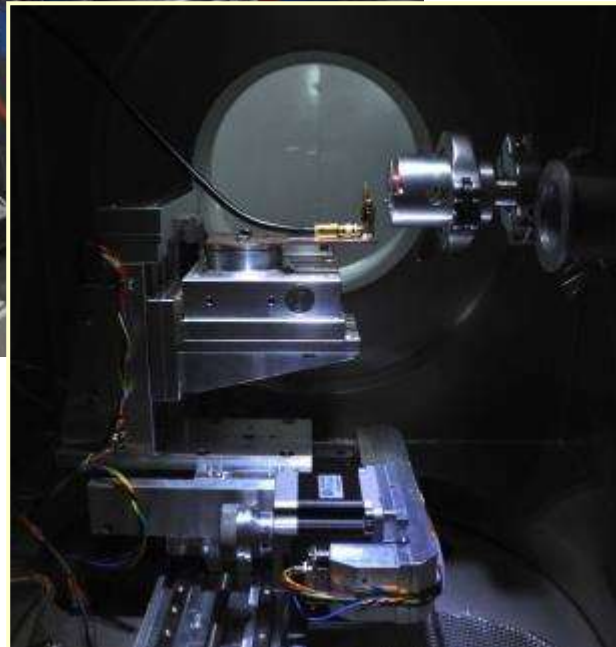
# IAEA BEAM LINE

Since 1996.

- Used up to 20 days/year by:
- IAEA staff (different projects)
  - IAEA trainees (TC projects)
  - Training courses



Beam line upgraded in 2012., by addition of irradiation chamber for detector testing.  
In 2016, original IAEA chamber is replaced by dual beam irradiation including microbeam



# **DiFU**

## **Dedicated Dual-ion Irradiation Facility for Fusion Materials**

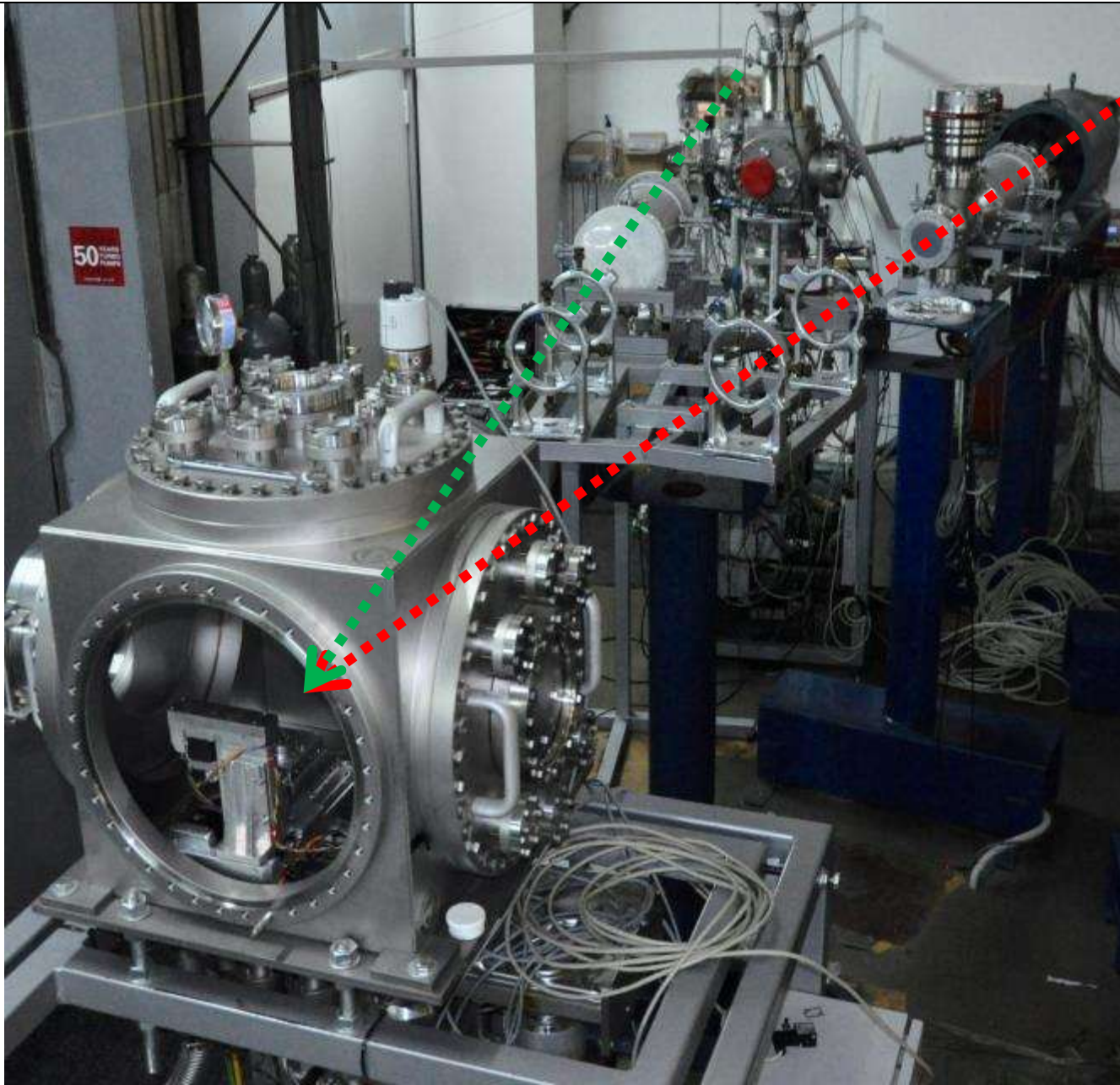
**RBI and Croatian fusion Research Unit (CRU)**



**European Fusion Programme – H2020 project EUROfusion  
WorkPackage Fusion Materials (WPMAT)  
- *SP Ion and Neutron Irradiation***

- a) Irradiation of samples by single-beam and dual-beam of ions on area from 5x5 to 30x30 mm<sup>2</sup>
- b) Electrostatic ion beam scanning, with high scanning frequency; flexible scanning area, pattern and frequency
- c) Homogeneous damage profiles in depth by adjusting of ion energy using beam degraders with rotating foils and/or varying of ion beams' energies
- d) Indirect ion beam profile/ion beam flux measurement using Micro-FCs;
- e) Sample positioning using XYZ $\Theta$  manipulator;
- f) Heating of sample and control of sample's temperature by IR camera and set of thermocouples;
- g) Gas-jet injection in front of irradiated area at the sample, if required;
- h) High vacuum ( $< 1 \cdot 10^{-7}$  mbar) using turbo-molecular pump, with ion pump added, to reduce creation of hydrocarbons at irradiated area of the sample.

Ion beam lines for DiFU station after precision alignment of components (June 2016)





# Expected heavy ion beam currents at DiFU station

Ion	Z	M	Ion Energy (MeV)	Neg. Ion Current (nA)	Ion charge +Q	Ion Rigidity ME/Q <sup>2</sup>	Termin. Voltage (MV)	Ionizat. Probab. %	Stripper MS Transmiss. %	Total Transmiss. %	Expected Ion Current (nA) In 6 mm Ø area
W	74	184	10	500	5	73.6	1.667	5.741	0.264	0.015	0.4
W	74	184	20	500	6	102.2	3.5	4.441	0.594	0.026	0.8
W	74	184	30	500	8	86.2	3.33	1.161	0.885	0.014	0.6
W	74	184	40	500	9	90.8	4.0	0.856	1.234	0.011	0.5
Fe	26	56	10	500	3	62.2	2.5	24.054	2.833	0.681	10
Fe	26	56	20	500	4	40	4.0	18.721	7.094	1.328	26
Fe	26	56	30	500	6	46.6	4.286	3.943	7.971	0.314	9
Fe	26	56	40	500	8	35	4.444	0.421	8.892	0.037	1.5
Cu	29	63	10	5000	3	70	2.5	23.210	2.307	0.553	80
Cu	29	63	20	5000	4	78.7	4	18.320	5.877	1.077	215
Cu	29	63	30	5000	6	52.5	4.286	4.111	6.687	0.275	82
Cu	29	63	40	5000	8	39.3	4.444	0.559	7.109	0.040	16

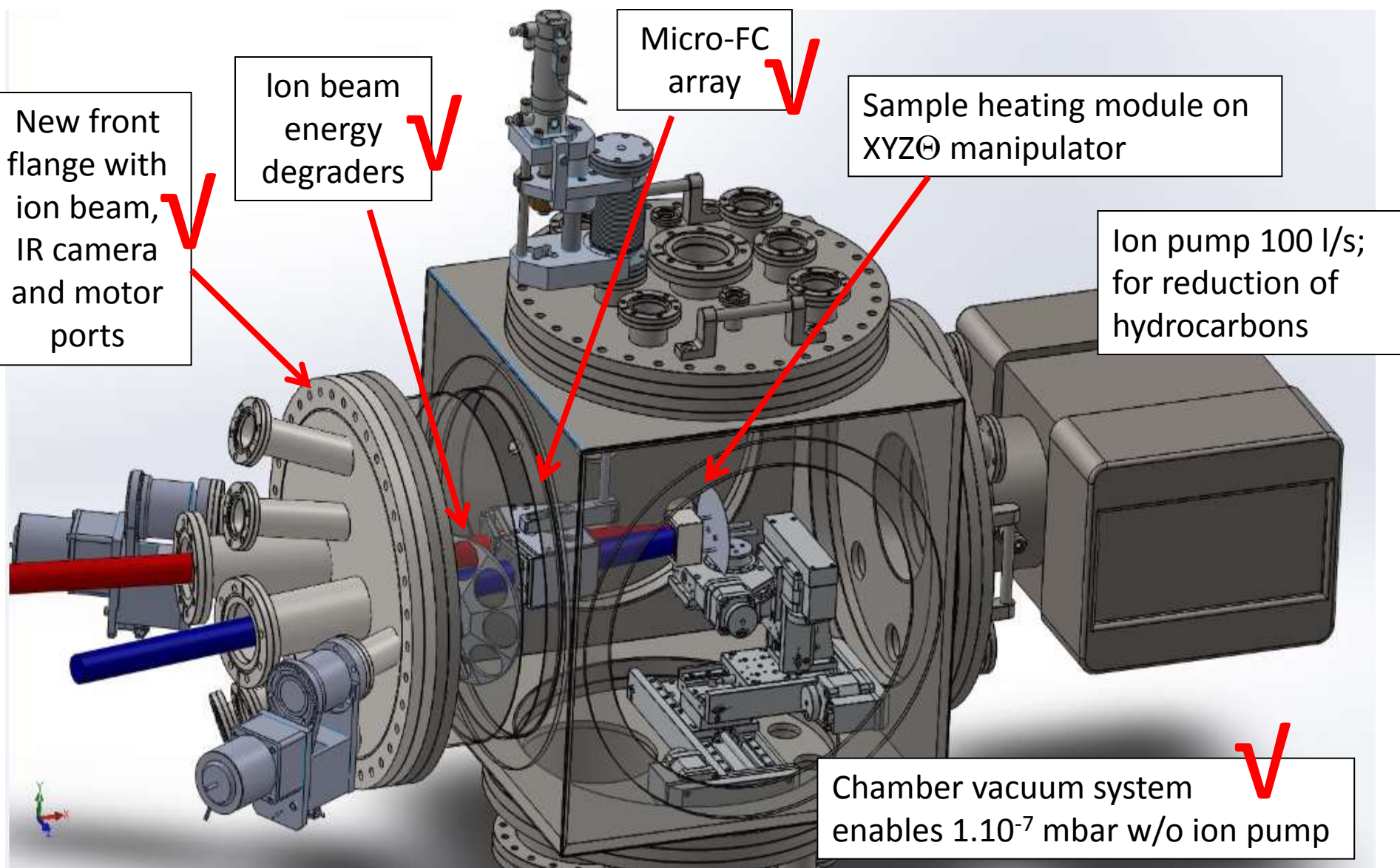
~20 nA

~12 nA

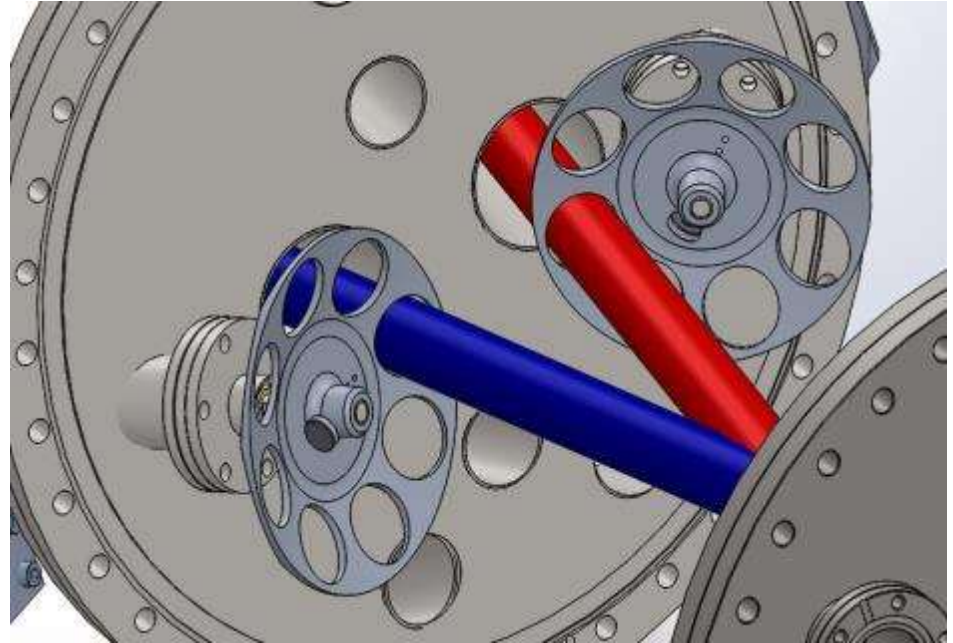
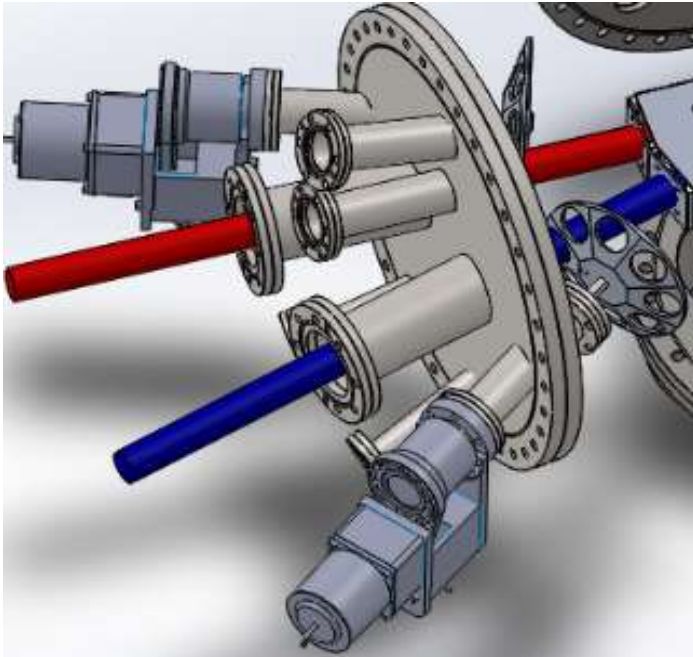
Measured in 10 mm Ø area in front of DiFU chamber ;

more trials are necessary with varying of Fe cathode, stripper gas density and ion optics

# Modifications of irradiation chamber for DiFU station



## Rotational ion beam energy degraders at DiFu station



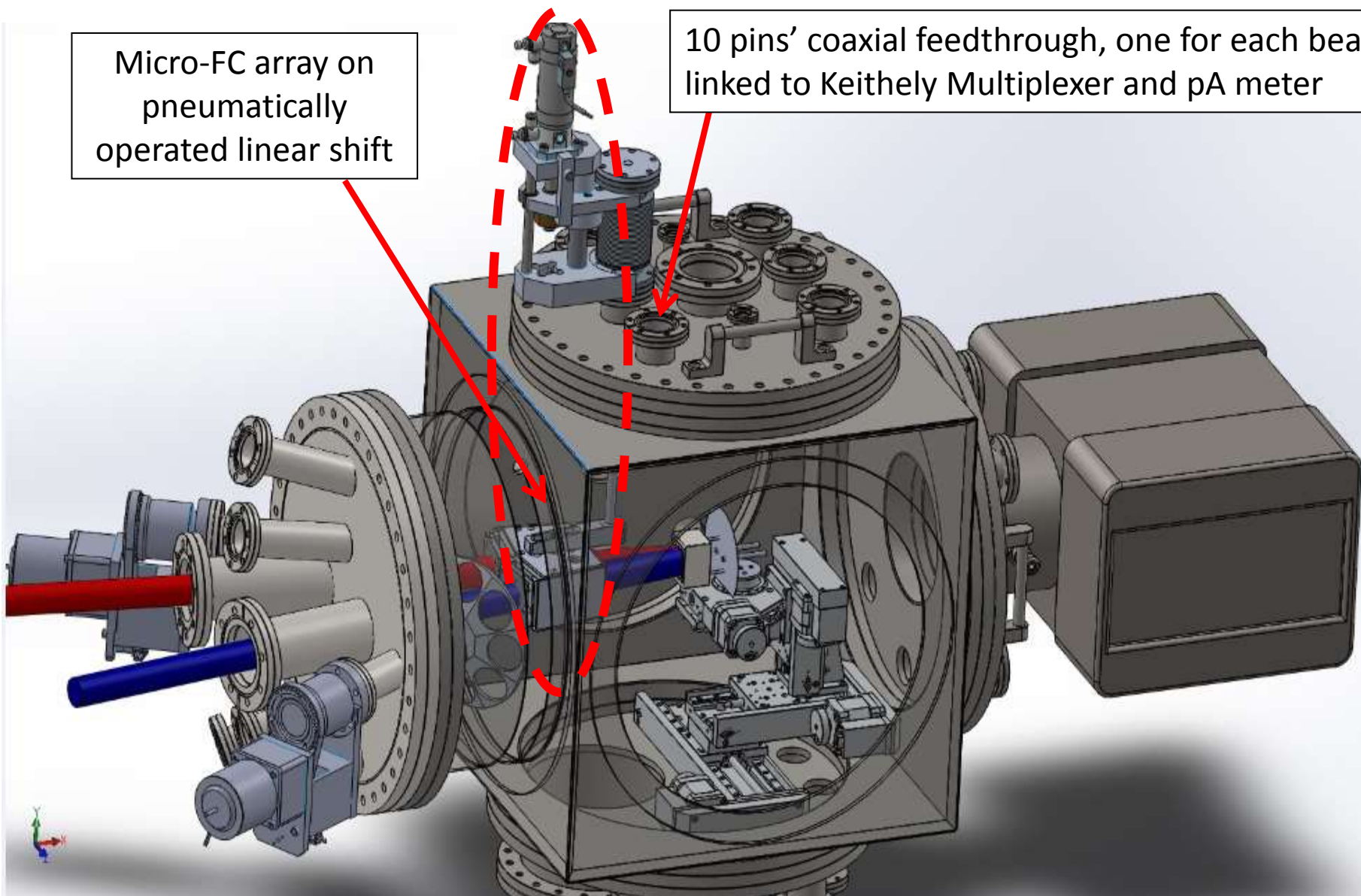
- Degraders shaped as 8-side pyramids, made of single Al block – good heat sink
- 1 empty + 7 foil-covered positions;
- Holes for foils of 35 mm diameter; foils 250 mm from sample surface
- Degraders fixed to rotating shaft & at  $20^\circ$  to the respective ion beam.



# Micro-FC Array for ion flux monitoring

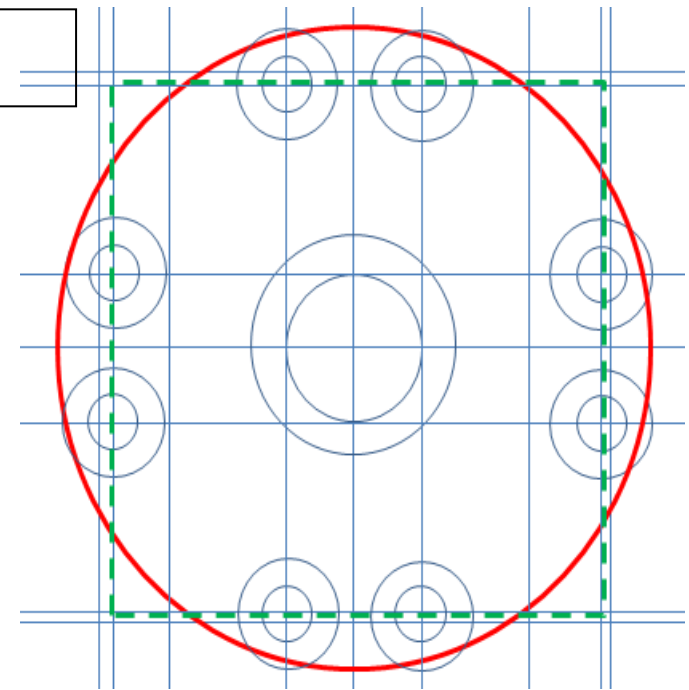
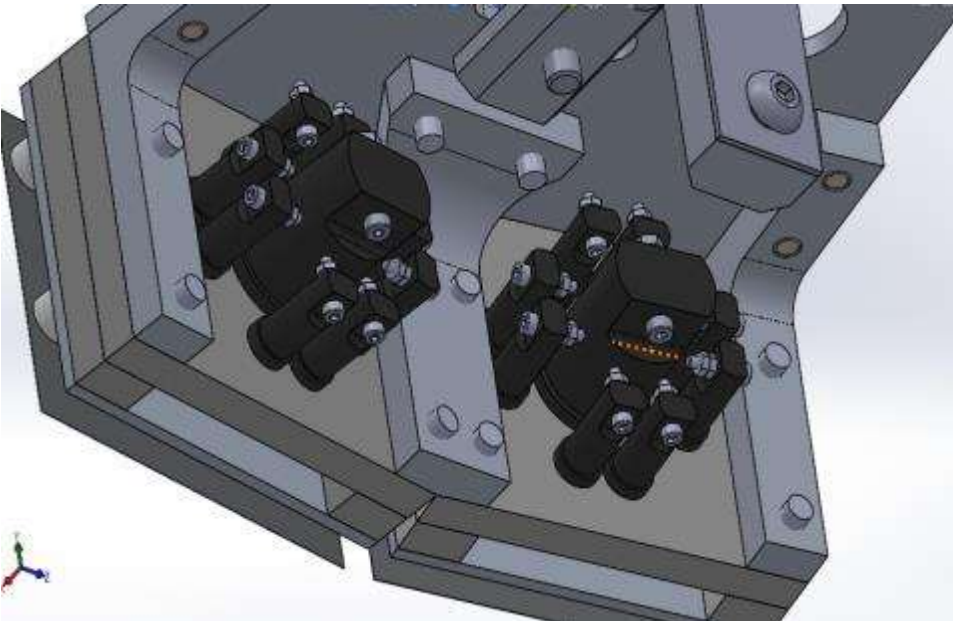
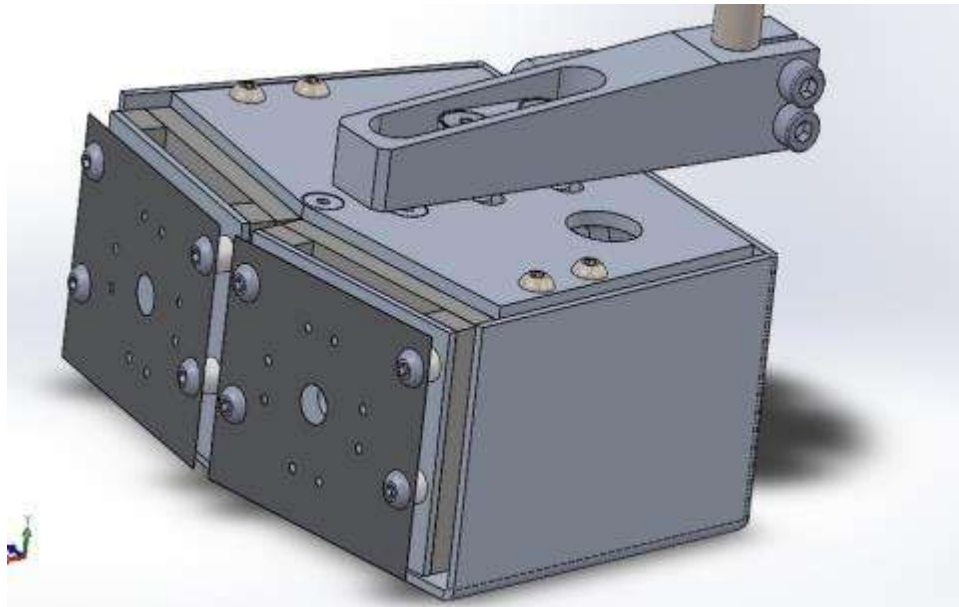
Micro-FC array on  
pneumatically  
operated linear shift

10 pins' coaxial feedthrough, one for each beam,  
linked to Keithley Multiplexer and pA meter





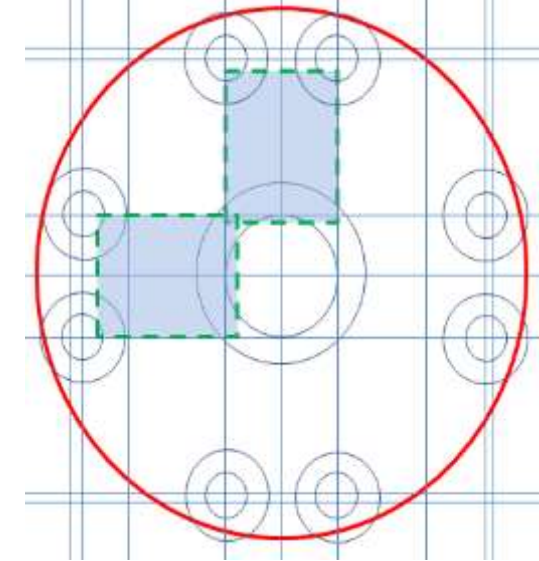
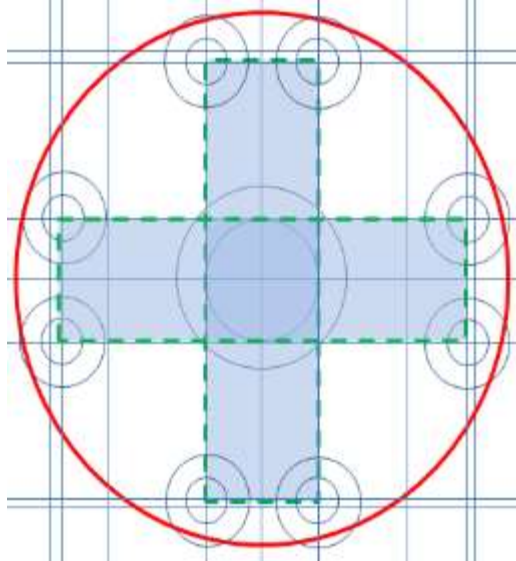
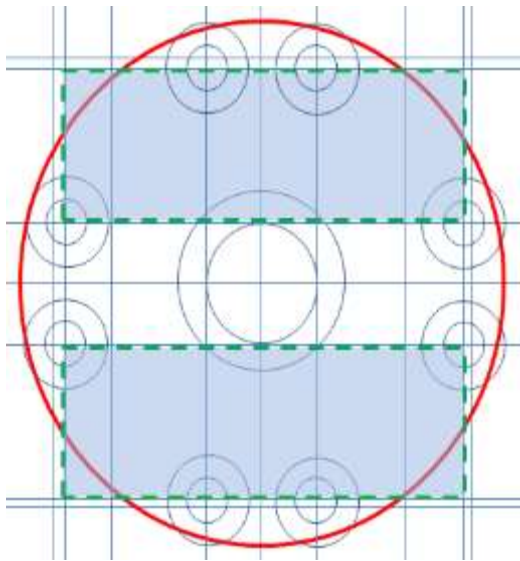
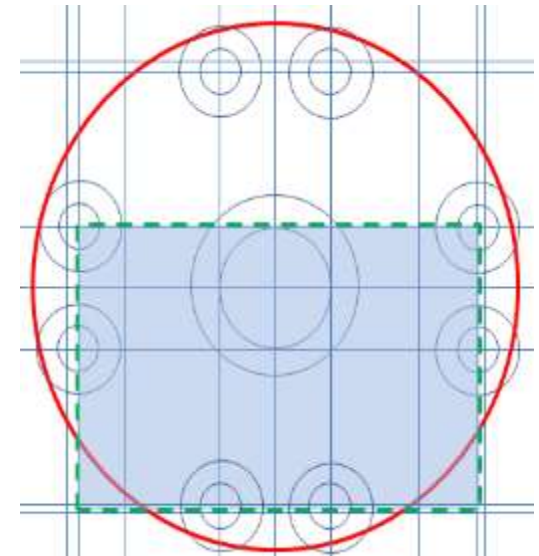
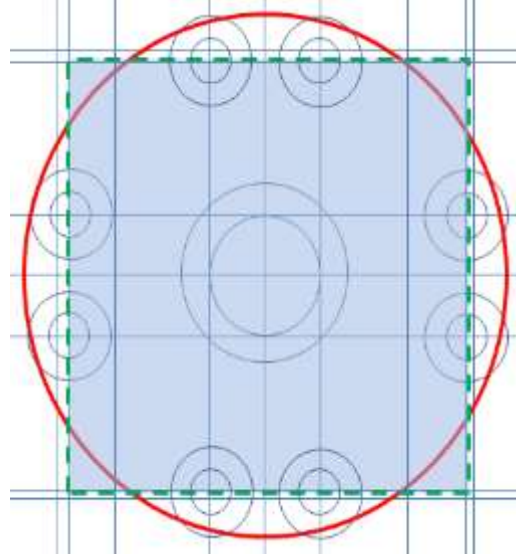
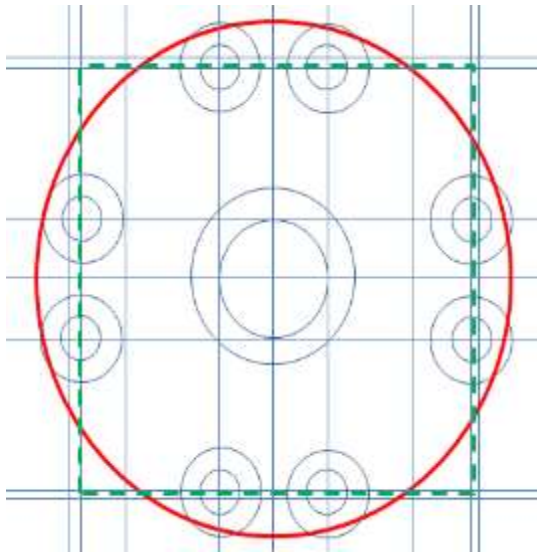
# Micro-FC Array for ion flux monitoring



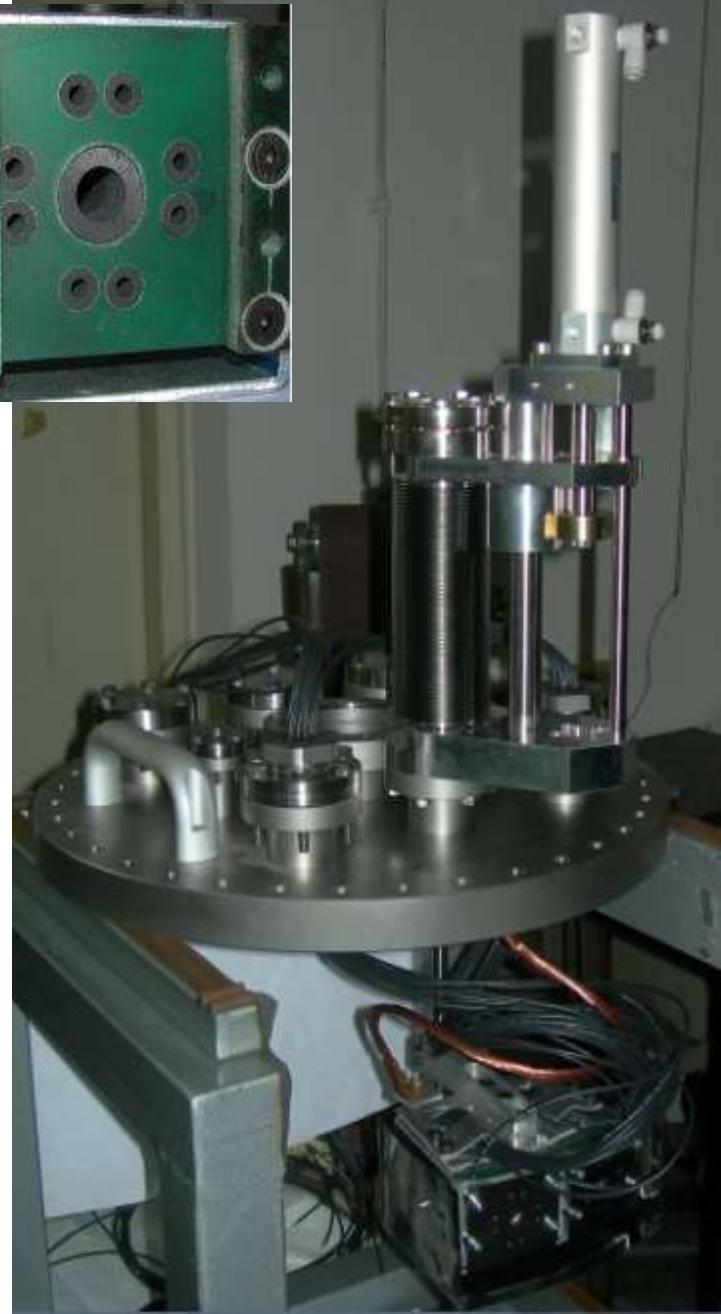
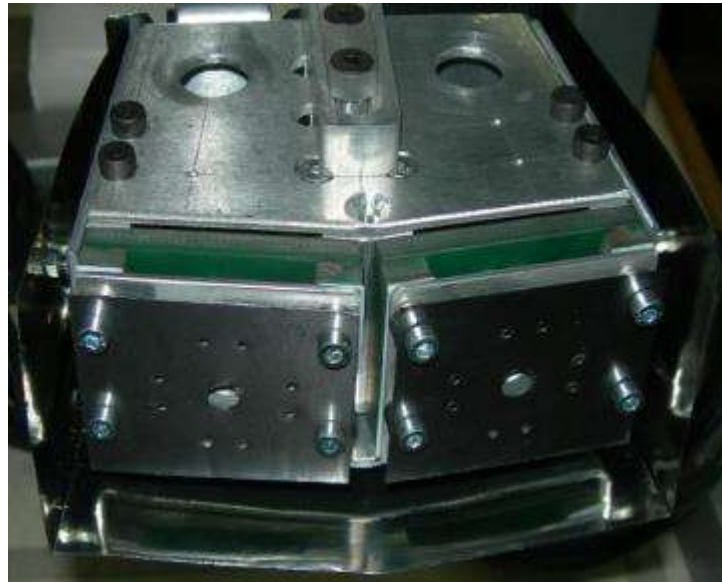
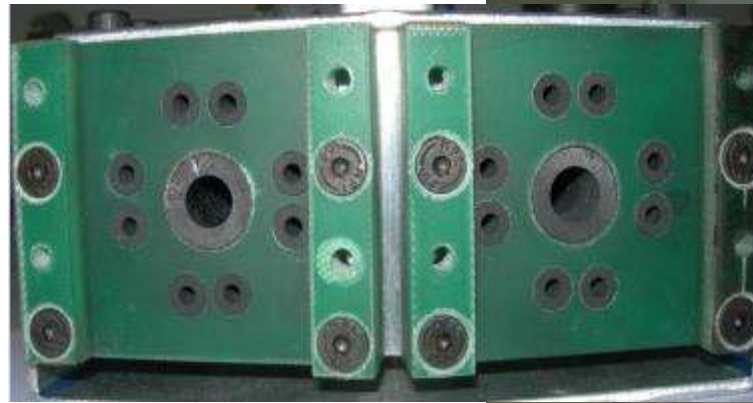
Planned configuration:

- Circle diameter 35 mm = size of Al foils at degrader; Dotted line 30x30 mm
- Central FC  $\varnothing 8\text{mm}$  + 8 x FCs  $\varnothing 3\text{mm}$
- Multiplexer & pA meter for sequential ion flux measurement (30s in each 30 min)
- Hardware and software developed for microbeam scanning enables pattern

# Various scanning areas monitored by Micro-FC array

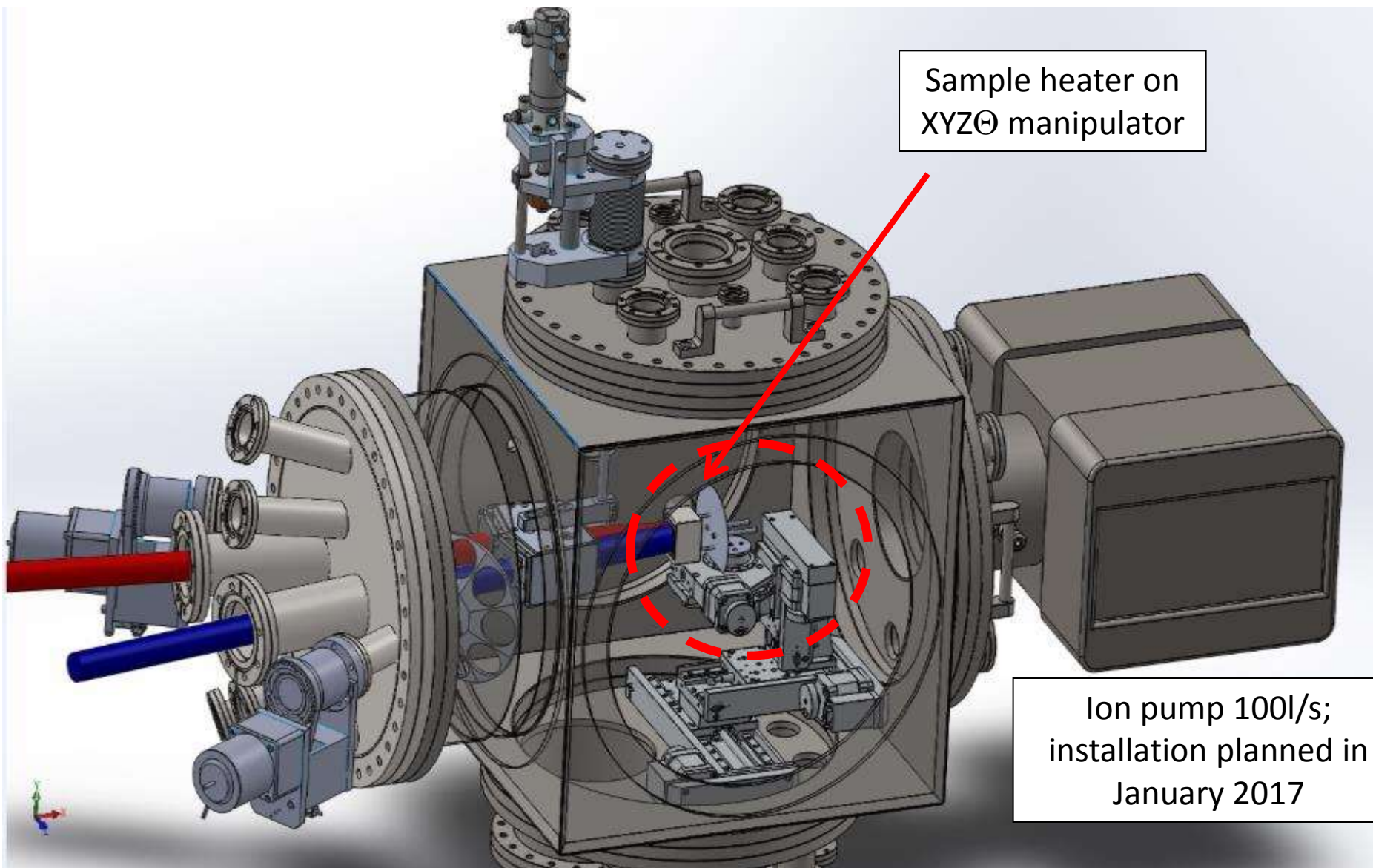


# Micro-Faraday Cup Array for monitoring of ion flux





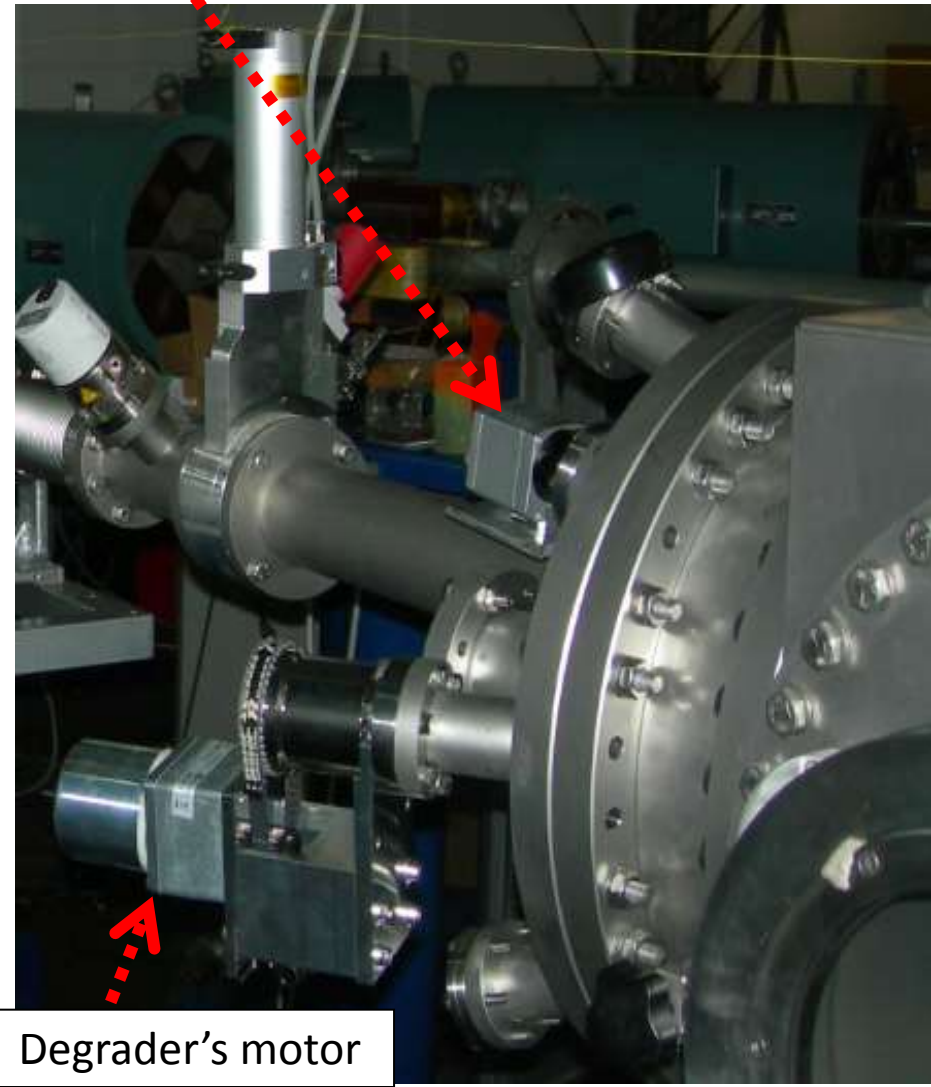
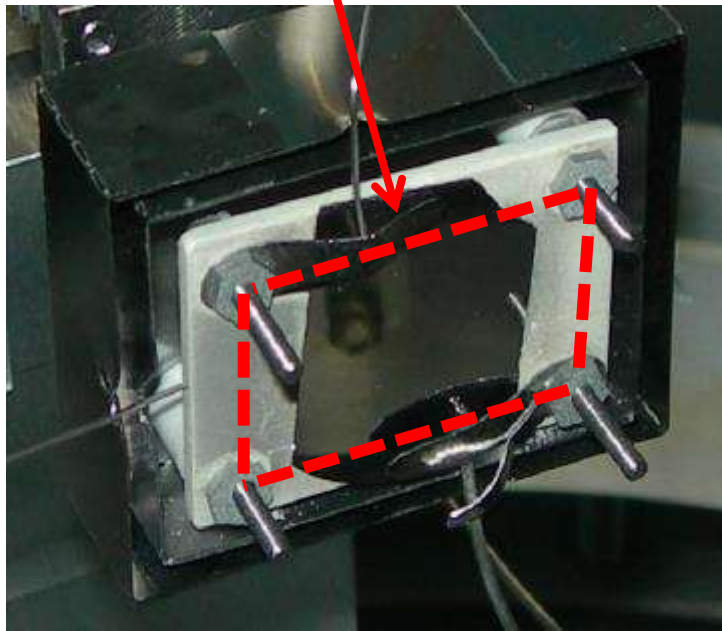
# Sample heater on XYZ $\Theta$ manipulator





Optris PI Infra Red Camera on ZnSe (uncoated) viewport;  
-20 to 900°C measurement temperature range; 75 mK resolution  
Up to 120 Hz real time video recording  
640x480 pixels; position resolution 0.4 mm

Installation of 3 K-type thermocouples  
at sample and TECTRA ohmic heater  
Max. operating temp:  $\sim 700^{\circ}\text{C}$   
Low volume & rapid cooling  
Heating area 35x25 mm



Degradation chamber motor

## Possible further upgrades:

- Ohmic heater with larger area: 50 x 75 mm; and/or
- IR quartz lamp heating of sample
- Active cooling of the sample
- FC-array on front frame – to avoid inserting of Micro-FC array
- Microscopy of irradiated samples
- Detectors for on-line IBA of irradiated samples
- Etc....

## Key principles:

- Prolonged irradiation with low currents
- Flexibility of experimental conditions
- Tailoring of the setup according to customers' needs & ideas

Manchester (UK), Rosendorf (DE), Saclay (FR), Zagreb (HR)



Multi-ion beam facilities in EU



**THANK YOU FOR ATTENTION!**

